

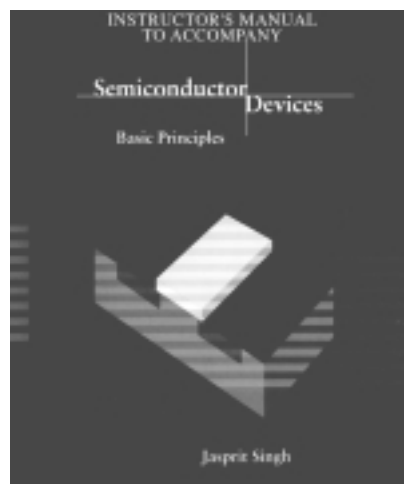
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# Chapter

# 11

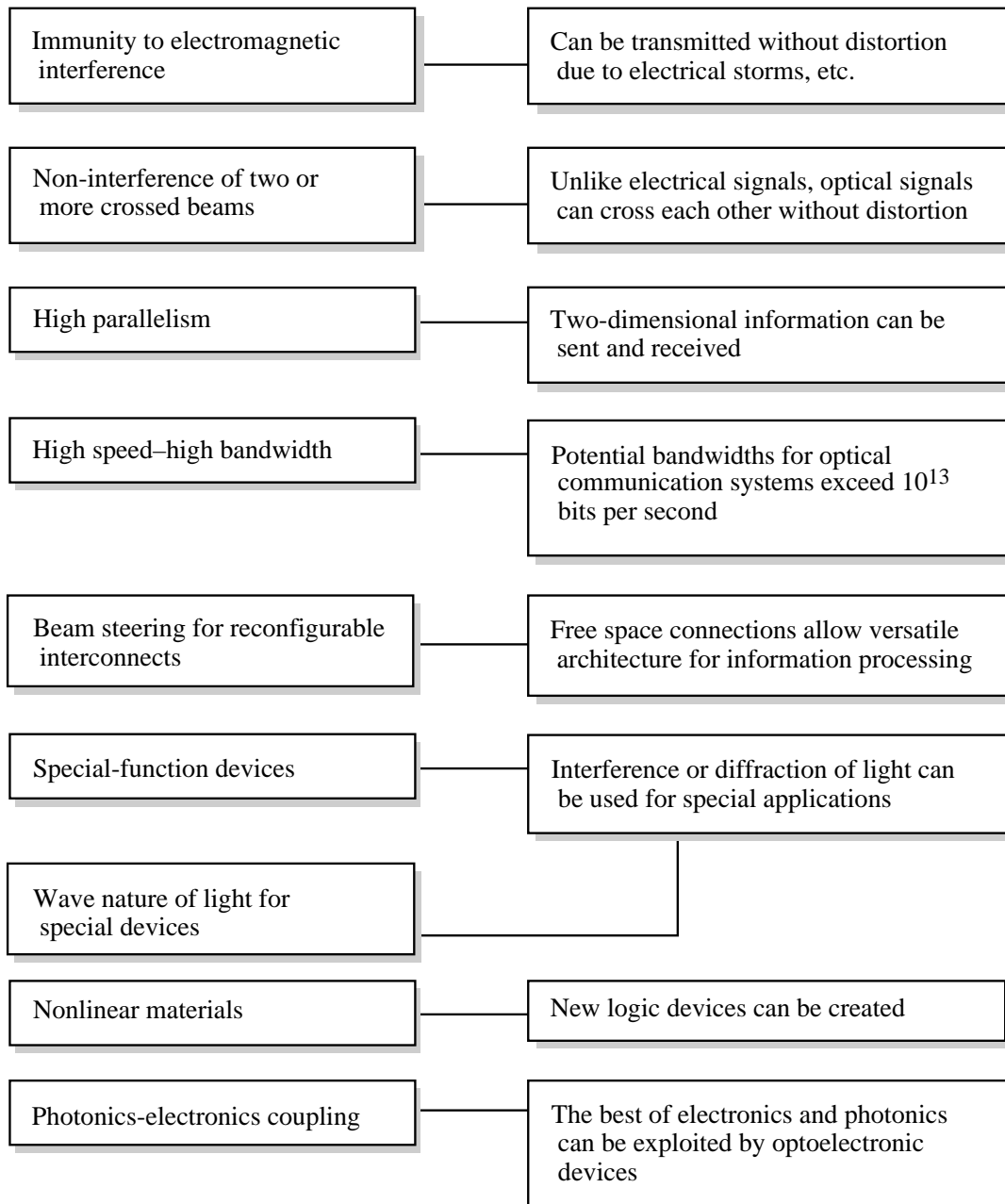
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## SEMICONDUCTOR OPTOELECTRONICS



Semiconductor based optoelectronic devices form an important component of modern information age. The following figures provide an overview of important optoelectronic processes and devices.

## ADVANTAGES OF OPTICAL DEVICES

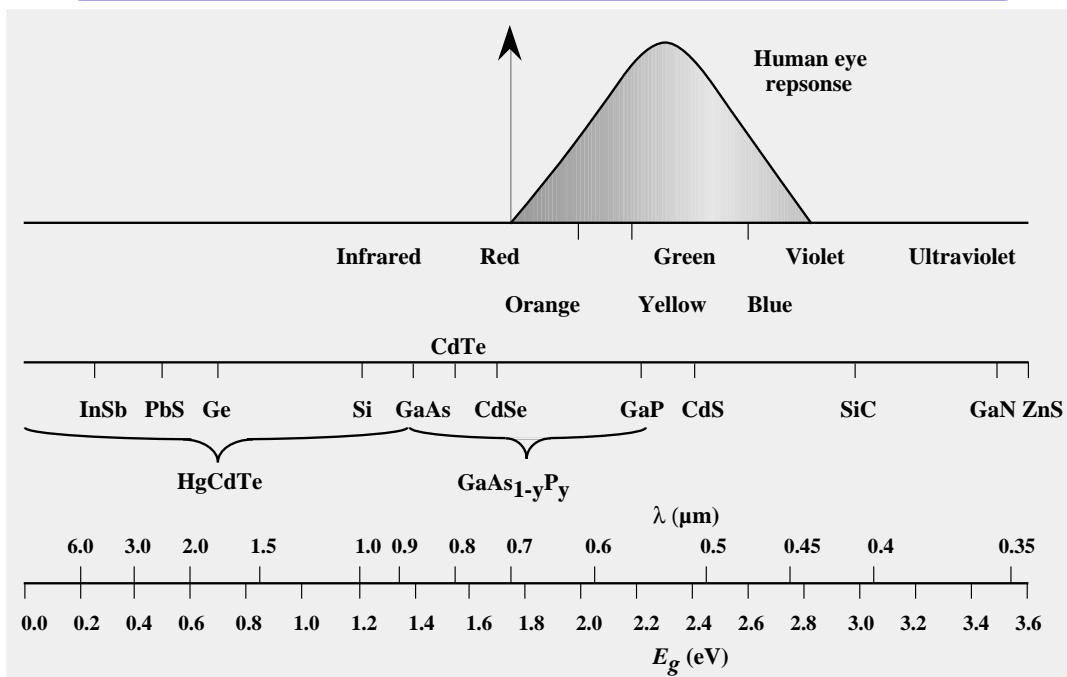


Challenges: How does one harness the tremendous potential?

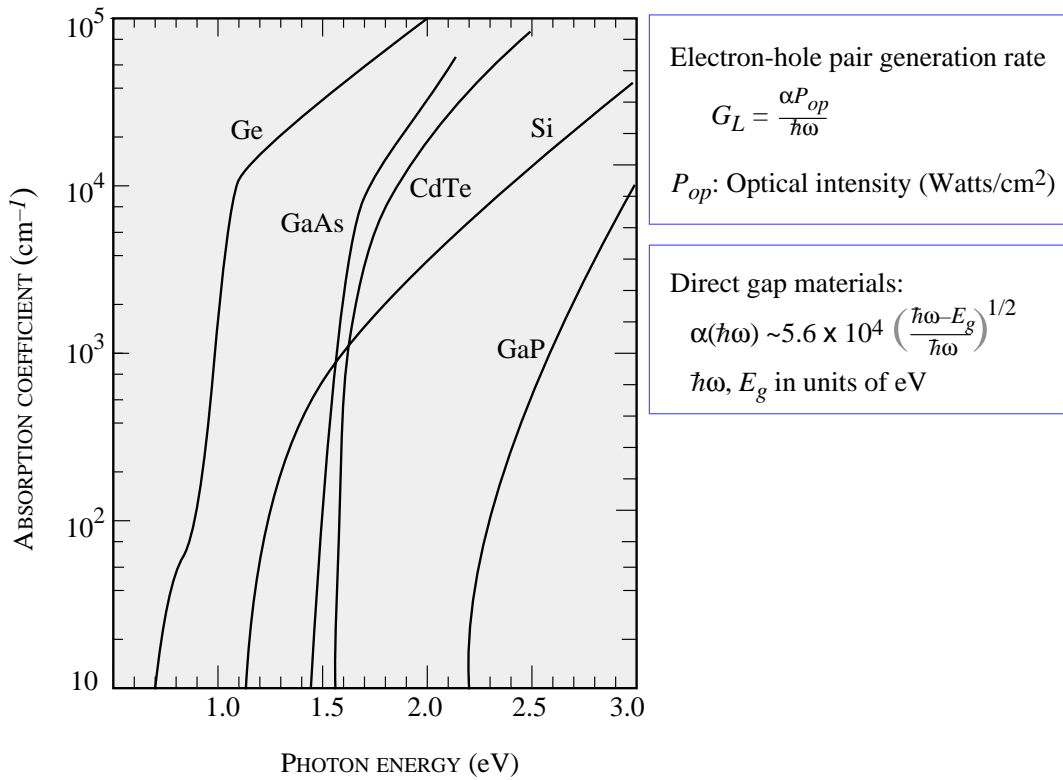
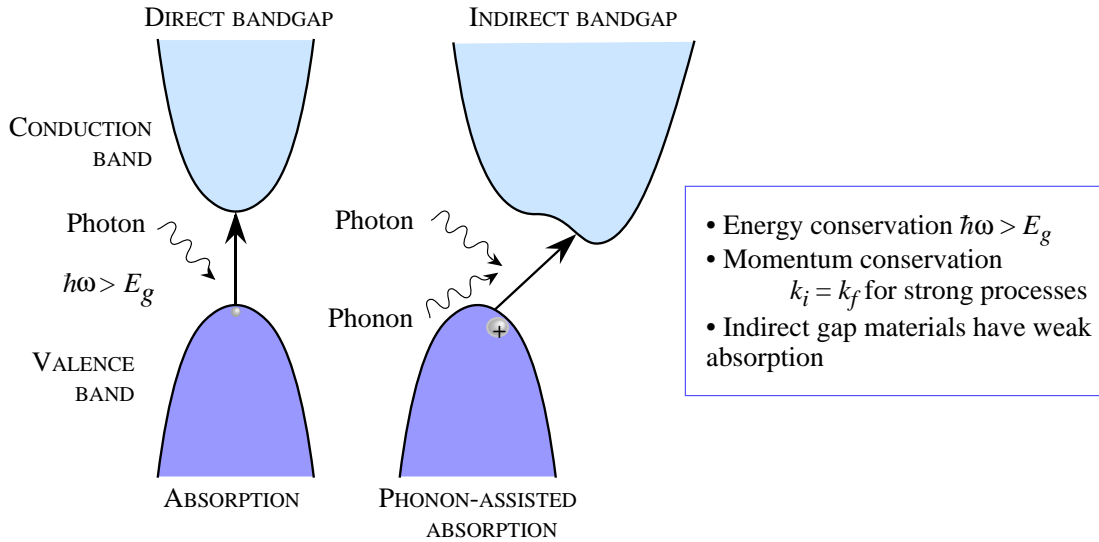
# OPTOELECTRONICS: MOTIVATIONS FROM SYSTEM DEMANDS

- DISPLAY APPLICATIONS: Light emitters covering red, green, blue
- OPTICAL MEMORIES: Short wavelength light emitters
- COMMUNICATIONS: Light emitters/detectors operating at low absorption/dispersion points of optical fibers (1.55  $\mu\text{m}$ , 1.3  $\mu\text{m}$ )

## SEMICONDUCTOR BANDGAPS (WAVELENGTHS) AND HUMAN EYE RESPONSE



# LIGHT ABSORPTION IN SEMICONDUCTORS



## P-I-N PHOTODETECTORS

The detector is reverse biased to collect any electron-hole pairs created by light absorption.

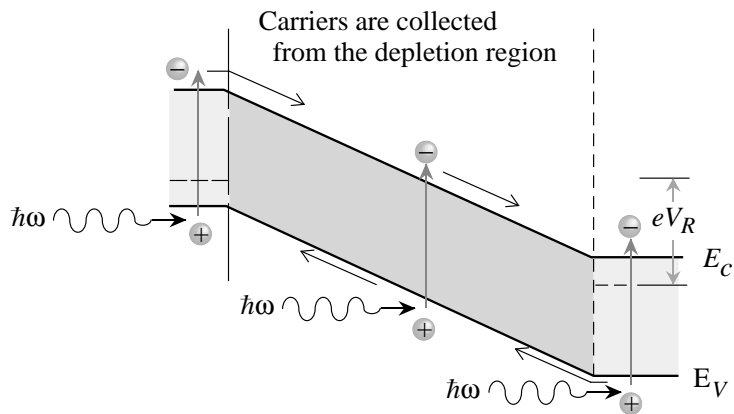
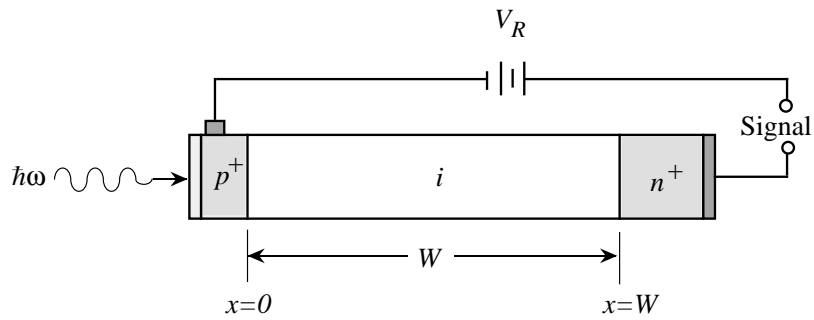
Photocurrent:

$$I_L = eAJ_{ph}(0)[1 - \exp(-\alpha W)]$$

$J_{ph}$  = Optical photon particle current

$W$  = Depletion region

$A$  = Device area

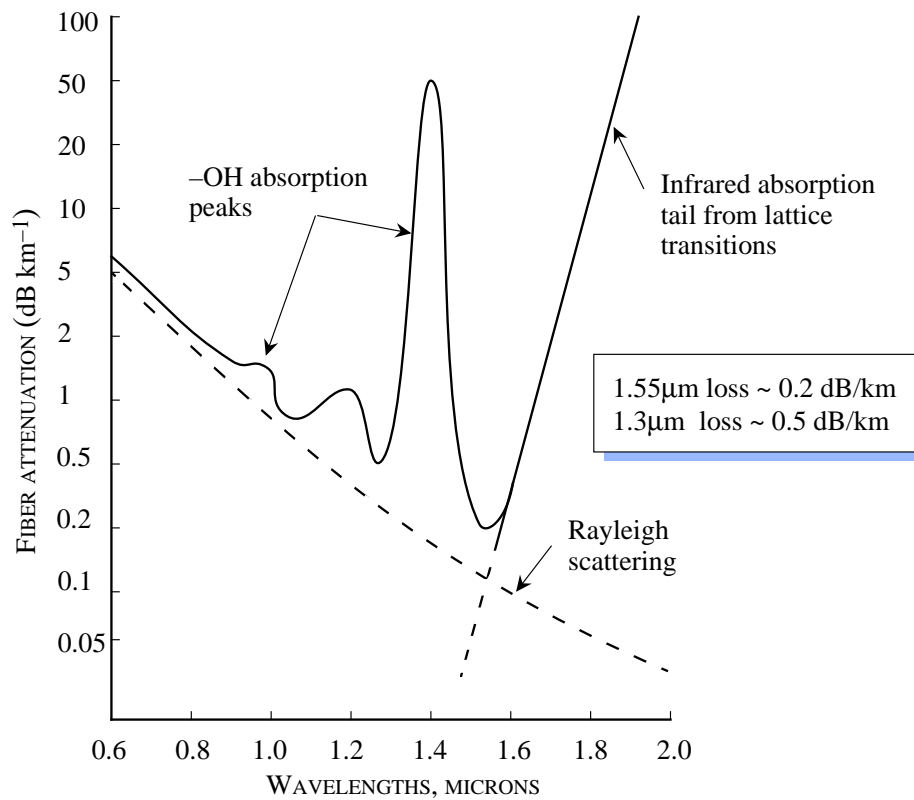


## SEMICONDUCTOR LIGHT EMITTERS FOR COMMUNICATION APPLICATIONS

Light emitters for long haul communication systems must emit light at  $\lambda = 1.55 \mu\text{m}$  or  $\lambda = 1.3 \mu\text{m}$ .

1.55  $\mu\text{m}$ : Lowest loss point in optical fibers

1.3  $\mu\text{m}$ : Lowest dispersion point in optical fibers

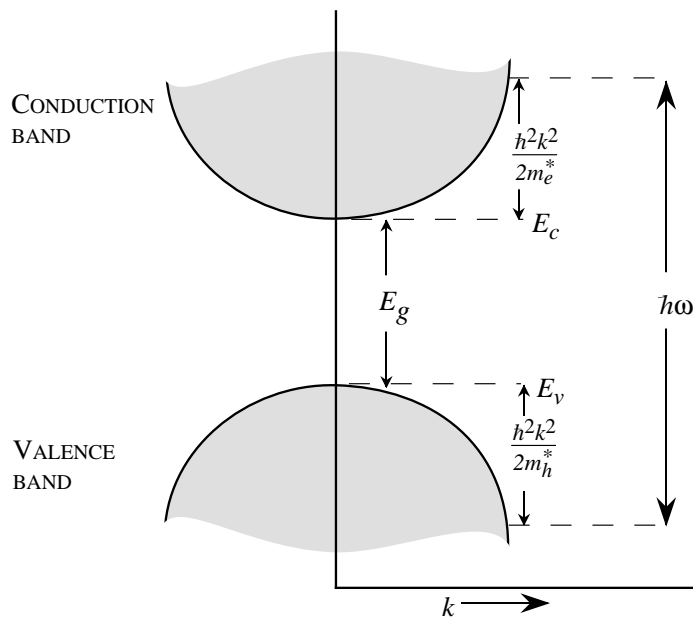


- GaAs lasers ( $\lambda \sim 0.88 \mu\text{m}$ ) are used for local area networks where distances to be covered are only a few kilometers.

- InGaAsP lasers are used for long haul communication. Optical pulses travel ~40-50 km and are then separated by repeater lasers. Optical fiber amplifiers are also used to boost the signal.



## LED: ELECTRON-HOLE RECOMBINATION TIME

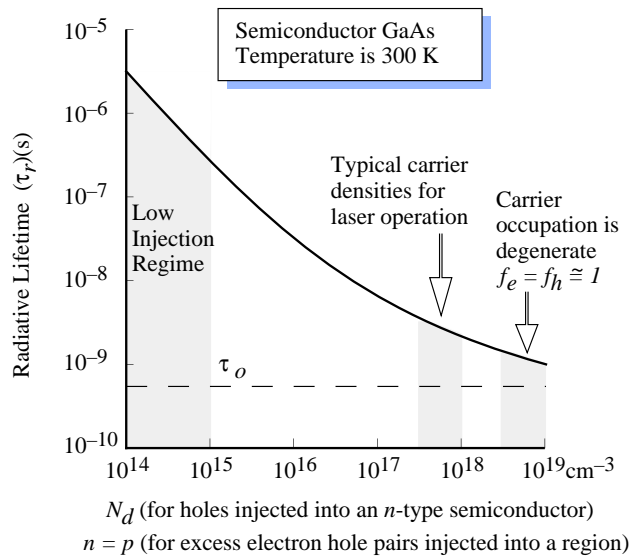


- Electrons and holes recombine in LEDs via a process called *spontaneous recombination*.
- Energy-momentum conservation rules apply.

Recombination rate  $\propto f^e(k) \cdot f^h(k)$

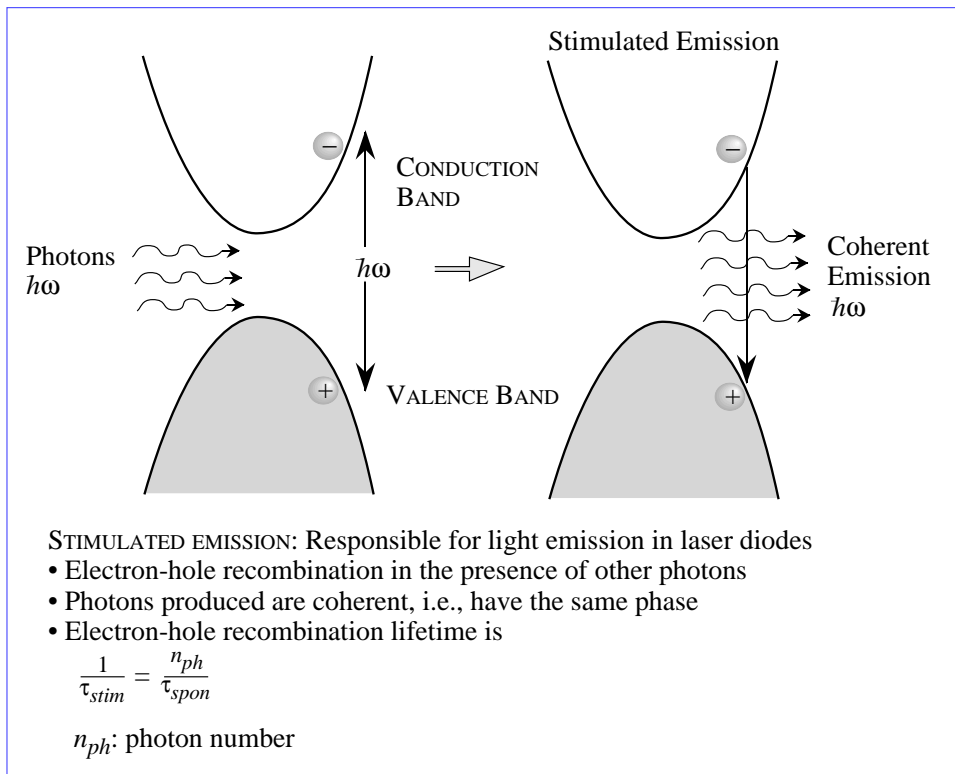
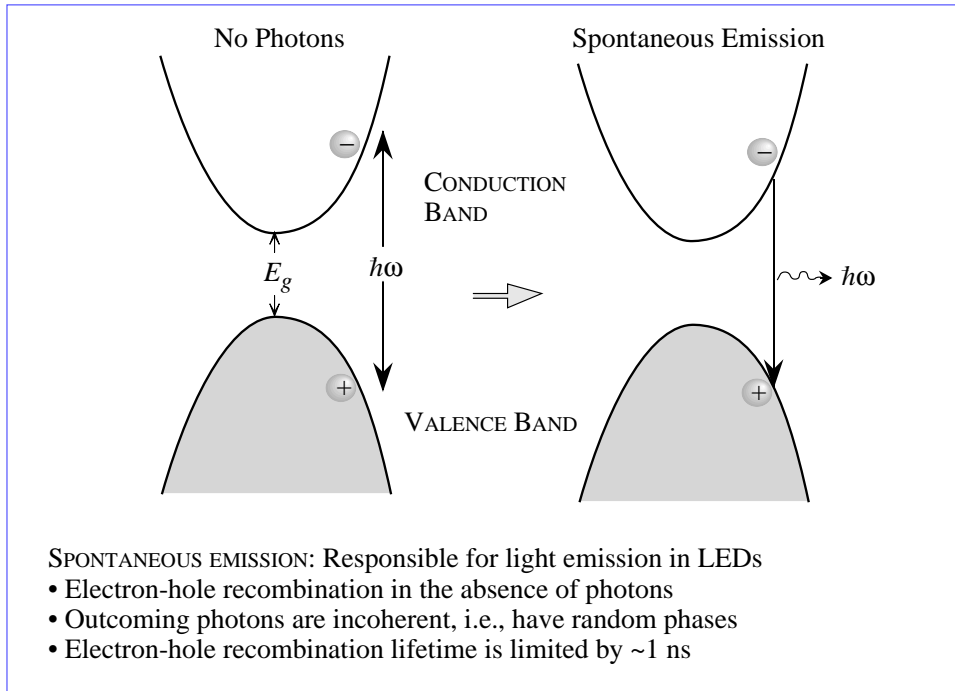
$f^e(k)$ : probability of finding an electron with momentum  $\hbar k$

$f^h(k)$ : probability of finding a hole with momentum  $\hbar k$

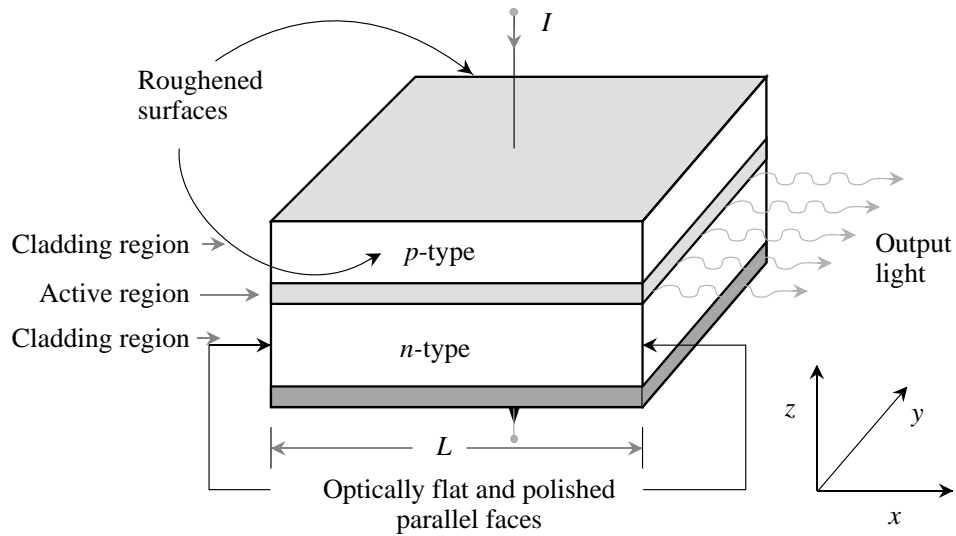


- Electrons-holes recombination time is a function of carrier density.
- At high carrier densities the  $e$ - $h$  recombination time approaches a nanosecond in most direct gap semiconductors.

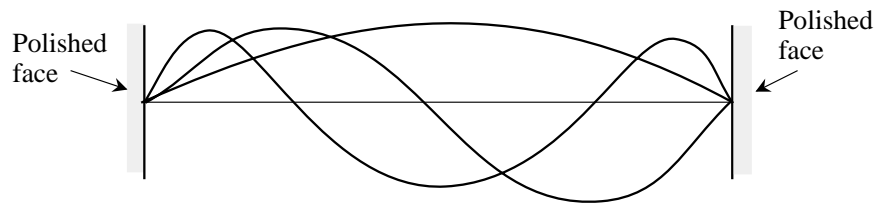
## STIMULATED EMISSION AND SPONTANEOUS EMISSION



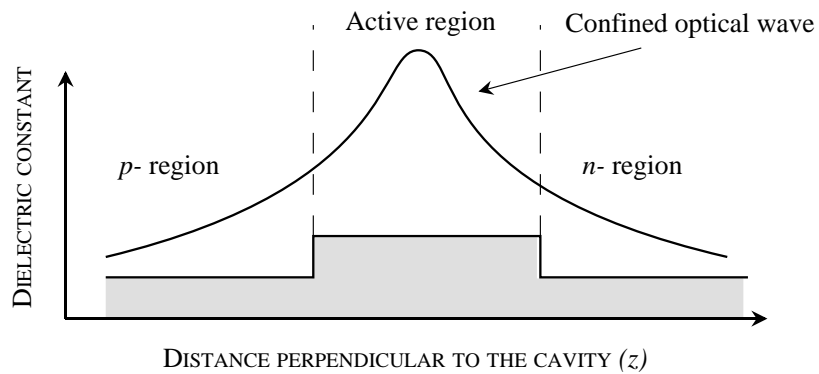
## THE LASER STRUCTURE: FORWARD BIASED P-N DIODE AND OPTICA CAVITY



Optical cavity, produced by cleaving the crystal causes photons to be reflected back into the cavity. The photon build-up starts the stimulated emission responsible for lasing



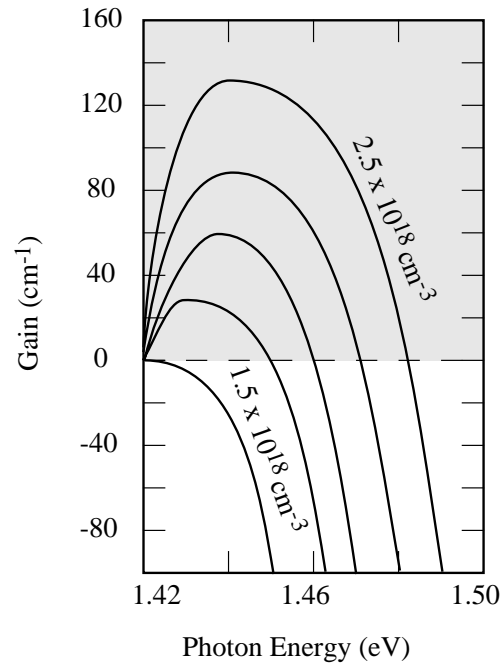
Optical modes in the cavity



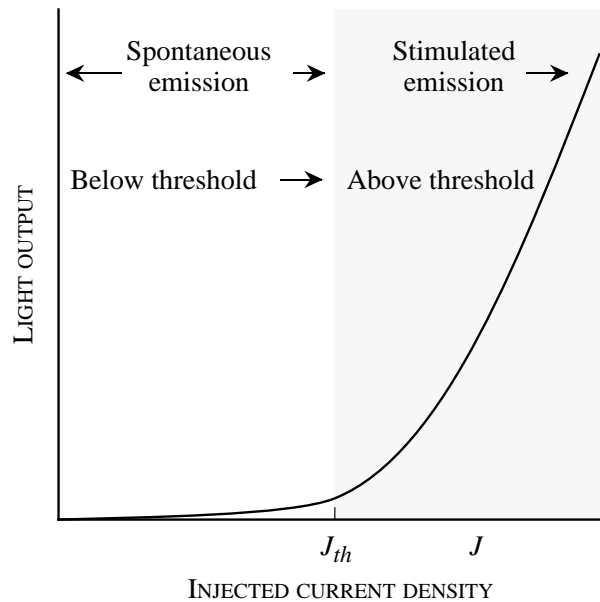
The light wave is confined in the cavity by the waveguide of the laser structure

## LASER OPERATION: GAIN AND LIGHT OUTPUT

- Gain = emission coefficient – absorption coefficient
- As more and more electrons and holes are injected into the active region of the laser the gain increases.
- When the gain overcomes the laser in the cavity, photon build-up occurs and lasing starts.



Light output in the *lasing mode* is very small below threshold. It increases rapidly once the laser is in the above threshold state.



# SPECTRAL OUTPUT OF A SEMICONDUCTOR LASER

